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** CONTINUING DATA *****

This application is a DIV of 10/188,369 07/03/2002 PAT 6,737,678

OK MC

** FOREIGN APPLICATIONS *****

JAPAN 2001-202496 07/03/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature <u>Maria G. Greiner</u> Initials <u>MC</u>	JAPAN	9	19	2

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TITLE

Method of fabricating nitride semiconductor device

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